



Attorney Docket No. ROH-039

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Patent Application of

Takashi Nakamura

Group Art Unit: 2818

Serial No. 09/856,818

Examiner: David Nhu

Filed: May 25, 2001

Confirmation No. 3701

FOR: METHOD OF FORMING INORGANIC COMPOUND SOLID AND METHOD OF
MANUFACTURING SEMICONDUCTOR DEVICE EMPLOYING THE SAME

5/9 Action
P. Walker
3-31-03

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, D.C. 20231

✓ Sir:

In response to the Office Action dated February 28, 2003, Applicant hereby elects
Species I, claims 1-22, with traverse.

It is respectfully submitted that the subject matter of all claims is sufficiently related
that a thorough search of the subject matter of any one group of claims would necessarily
encompass a search for the subject matter of the remaining claims. Thus, it is respectfully
submitted that the search and examination of the entire application could be made without
serious burden. See MPEP 803 which is stated that "if the search and examination of an
entire application can be made without serious burden, the examiner must examine it on the
merits, even though it includes claims that are distinct or independent inventions".

It is respectfully submitted that this policy should apply to the present application in
order to avoid unnecessary delay and expense to Applicants and the duplicative
examination by the Patent Office. Receipt of the initial Office Action on the merits is awaited.

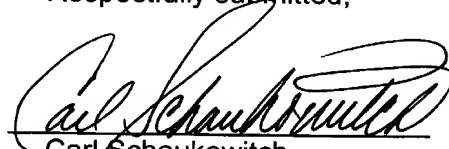
In the event that any additional fees are required with respect to this paper, the
Commissioner is hereby authorized to charge our Deposit Account No.18-0013.

Respectfully submitted,

Date:

3/27/03

By:


Carl Schaukowitch

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